



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

**Zahorik et al.**

**Serial No.: 10/647,634**

**Filed: August 25, 2003**

**For: METHODS FOR SELECTIVE  
REMOVAL OF MATERIAL FROM  
WAFER ALIGNMENT MARKS**

**Confirmation No.: 3991**

**Examiner: L. Vinh**

**Group Art Unit: 1765**

**Attorney Docket No.: 2269-3131.6US  
(96-1119.06/US)**

*Do NOT ENTER*

*LV  
12/16/08*

**CERTIFICATE OF MAILING**

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December 5, 2005  
Date

*Leta M. Howard*  
Signature

Leta M. Howard  
Name (Type/Print)

**AMENDMENT UNDER 37 C.F.R. §1.116**

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Commissioner for Patents  
PO Box 1450  
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Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Final Office Action mailed October 5, 2005, the three-month shortened statutory period for response to which expires on January 5, 2006. This response is submitted on or before two months from the mailing date of the Final Office Action.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.